

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of:

Li-Wen Chen, et al.

Serial No.: NYA

Filed on: January 26, 2004

For: METHOD FOR DYNAMIC PROFILING

Group Art Unit No.: NYA

Examiner: NYA

Confirmation No.: NYA

**PRELIMINARY AMENDMENT**

Mail Stop Patent Application  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the above-referenced application, please amend the application as follows: